

# A Zero Ion Backflow electron multiplier operating in noble gases

Fernando D. Amaro, E.D.C. Freitas, C.A.O. Henriques, M.R. Jorge, M. Ball, J.F.C.A. Veloso, J.M.F. dos Santos

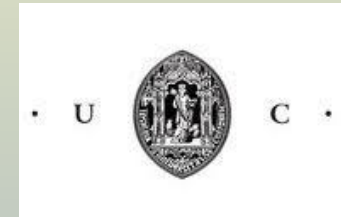
Coimbra University, Portugal

Aveiro University, Portugal

Technische Universität München, Germany



Technische Universität München



# Ion Back Flow in gaseous electron multipliers

- Ions in gaseous detectors
- Primary Ions.
  - Secondary Ions. From gas amplification at the readout.

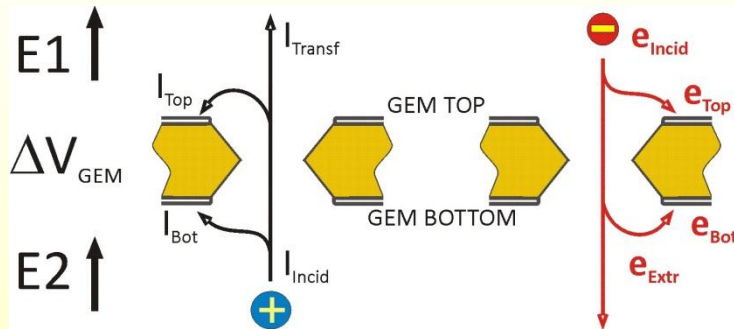
Ion Back Flow (IBF) is the ratio of ions that reach the cathode of the detector to the electrons collected at the anode.

In a open geometry (wire) detector this figure is =1. All ions are collected at the cathode.

Slow moving ions in the drift volume = Field distortions = track distortion.

# Ion Back Flow in gaseous electron multipliers

The development of the hole type multipliers (GEM) and the cascading of these electron multipliers, allowed a significant reduction of the IBF.



**3-GEM:** IBF of 0.5% At a gain of  $10^4$  and a drift field of 0.2 kV/cm (the goal is 1/G).

M. Killenberg, S. Lotze, J. Mnich, A. Munnich, S. Roth, F. Sefkow, M. Tonutti, M. Weber, P. Wienemann. Charge transfer and charge broadening of GEM structures in high magnetic fields, Nuclear Instruments and Methods in Physics Research A 530 (2004) 251-257.

Pulsed electrodes/GEM acting as gate for the ions  
limited count rate -> not feasible in ILC (?)

# Alternative Solutions

- DC trapping of ions (R-MHSP)

Successful operation of Gaseous Photomultiplier equipped with a visible sensitive photocathode

[A. Lyashenko, et al. Nuclear Instruments and Methods in Physics Research Section A 610 (2009)]

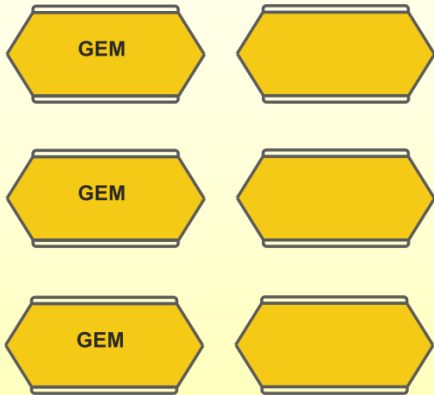
- Use of the secondary scintillation to propagate the signal in the detector  
(PACEM & Zero IBF electron multiplier)

[J. F. C. A. Veloso, et al. “The Photon-Assisted Cascaded Electron Multiplier: a concept for potential avalanche-ion blocking”, 2006 JINST 1 P08003]

[F. D. Amaro et al. “Zero Ion Backflow electron multiplier operating in noble gases, 2014\_JINST\_9\_P02004]

# Ion Back Flow- Alternatives

Standard Cascaded  
Electron Multiplier



**Electric Field  
Optimization**

IBF = 0.5% at a gain of  
 $10^4$ .

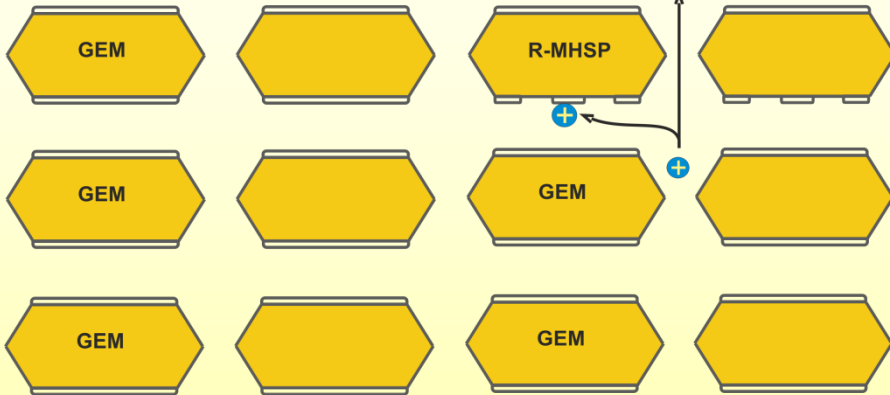
50 ions/primary  
electron

# Ion Back Flow- Alternatives



Standard Cascaded  
Electron Multiplier

“Reversed” MHSP



**Electric Field  
Optimization**

IBF = 0.5% at a gain of  
 $10^4$ .

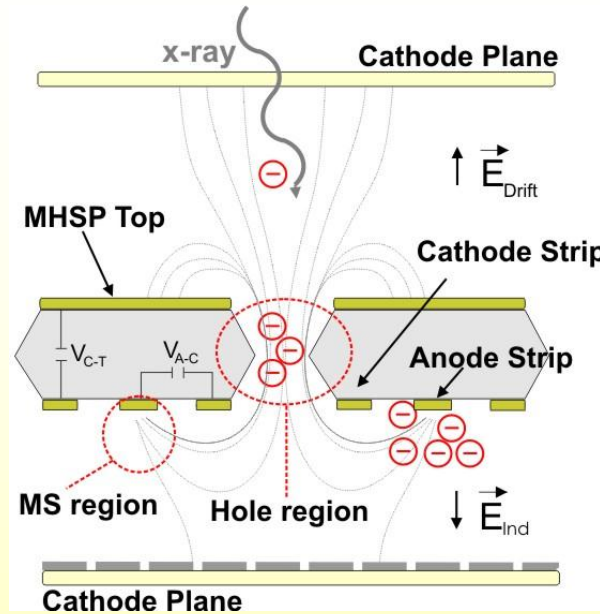
50 ions/primary  
electron

**Trapping of ions at the  
strips on the MHSP**

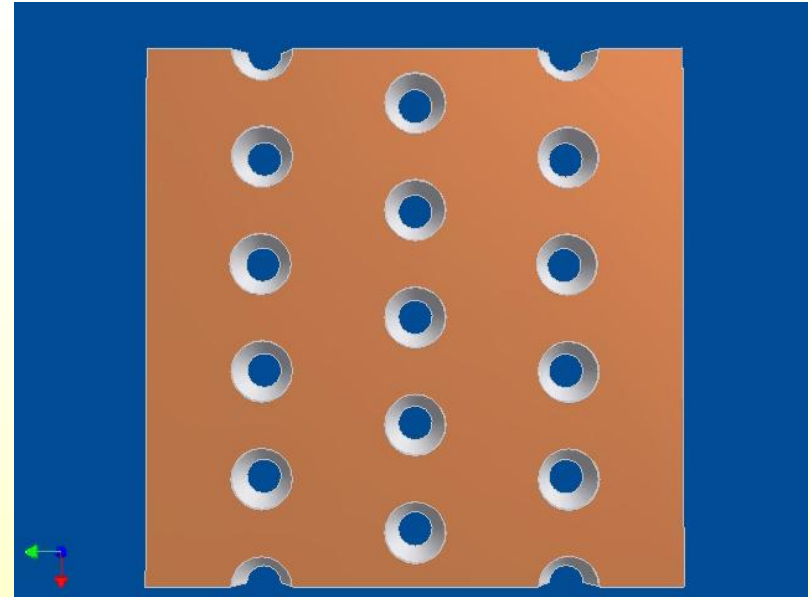
IBF = 0.06% at a gain  
of  $10^4$ .

6 ions/primary  
electron

# The Micro Hole and Strip Plate (MHSP)

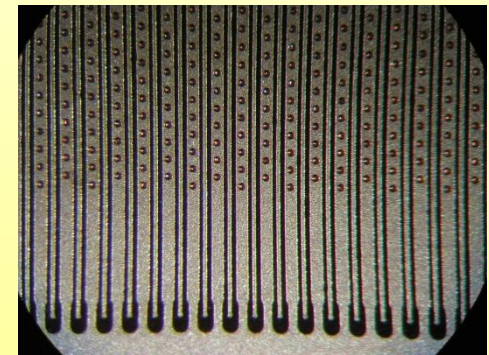


[J. F. C. A. Veloso, et al., Rev. Sci. Instrum. 71 (2000).]

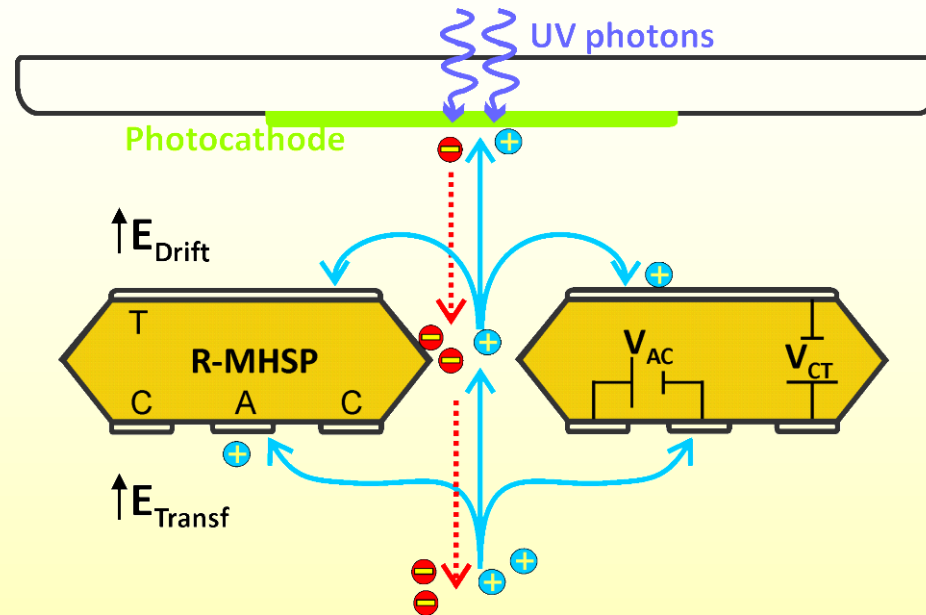


- Same technology as GEM
- 3 Independent set of Electrodes:
  - **Top** similar patterned as GEM
  - Bottom side has 2 type of electrodes, **Cathodes** and **Anodes**, in a micro-strip pattern.

High gain in a single structure



# The MHSP Reverse mode operation



Replacing the first GEM of a cascade by an MHSP.

This MHSP is operated in “reversed mode”, that is, with the anodes at a lower potential than the cathodes:

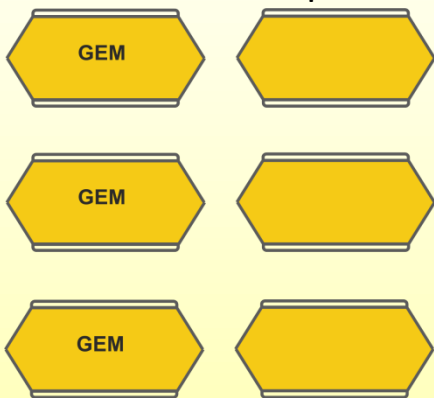
- no multiplication between the anode-cathode strips
- trapping of positive ions backflowing from the lower stages of the cascade.



# Ion Back Flow- Alternatives



Standard Cascaded  
Electron Multiplier

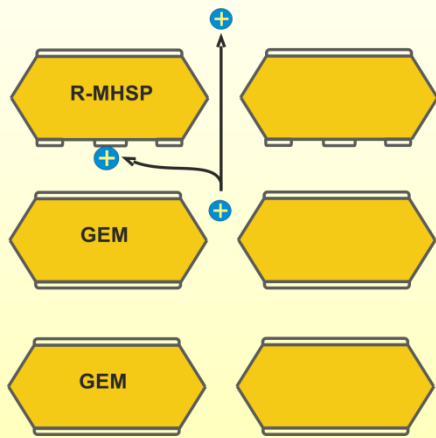


**Electric Field  
Optimization**

IBF = 0.5% at a gain of  $10^4$ .

50 ions/primary  
electron

“Reversed” MHSP

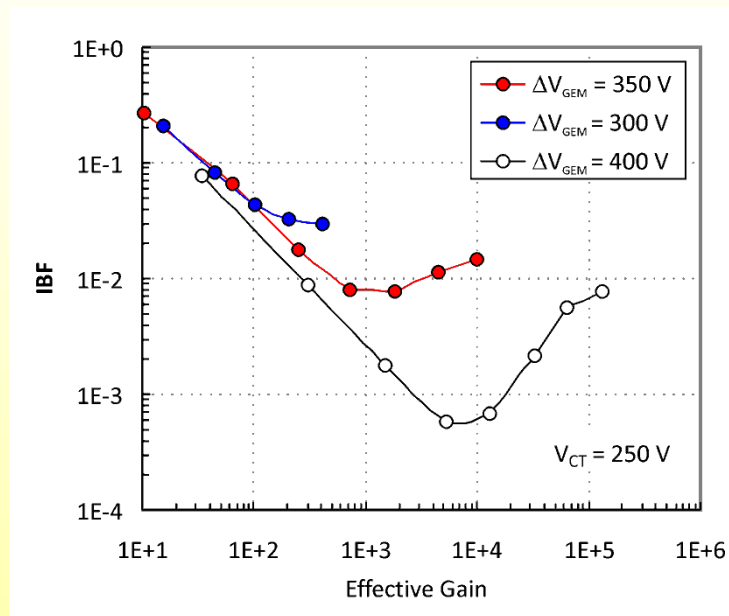


**Trapping of ions at the  
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IBF = 0.06% at a gain  
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6 ions/primary  
electron

IBF is dependent on gain



# Ion Back Flow- Alternatives

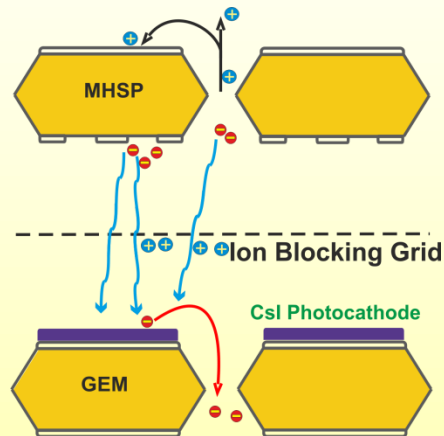
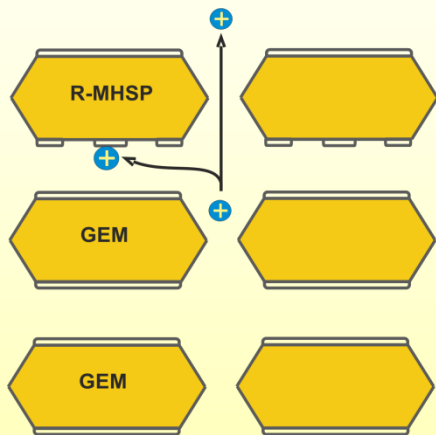
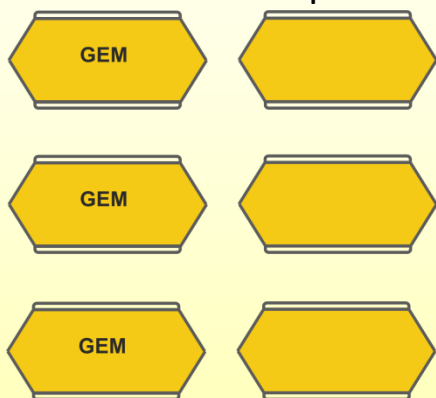
Ar/CH<sub>4</sub>

Noble gases and CF<sub>4</sub>

Standard Cascaded  
Electron Multiplier

“Reversed” MHSP

PACEM



**Electric Field  
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IBF = 0.5% at a gain of  
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6 ions/primary  
electron

**Use of secondary  
scintillation on MHSP**

**To propagate the  
signal**

**IBF independent on  
GAIN**

2 ions/primary  
electron (CF<sub>4</sub>)

# Ion Back Flow- Alternatives

Ar/CH<sub>4</sub>

Noble gases and CF<sub>4</sub>

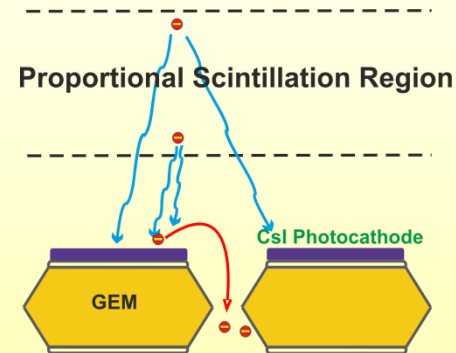
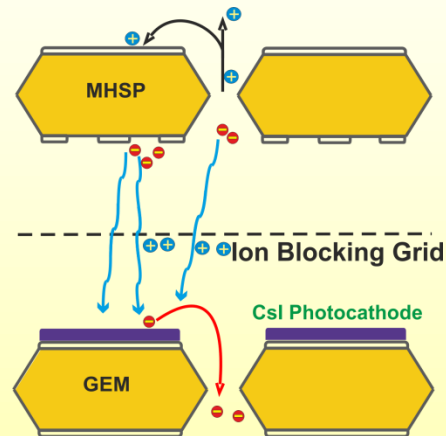
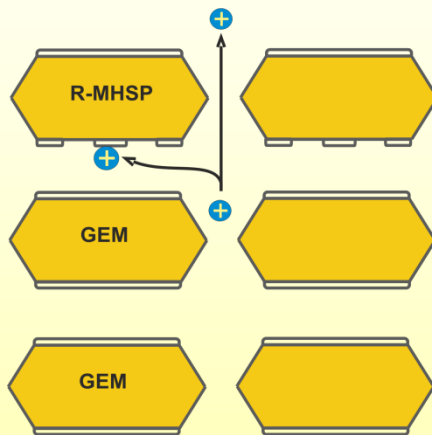
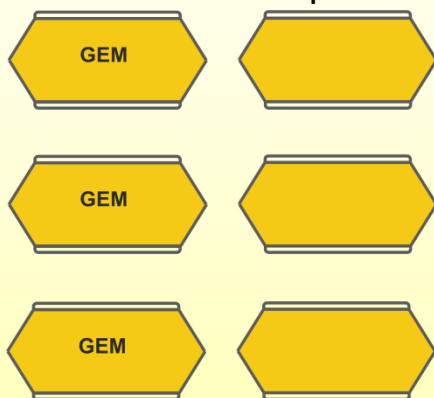
Noble gases

Standard Cascaded  
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ZERO IBF



**Electric Field  
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50 ions/primary  
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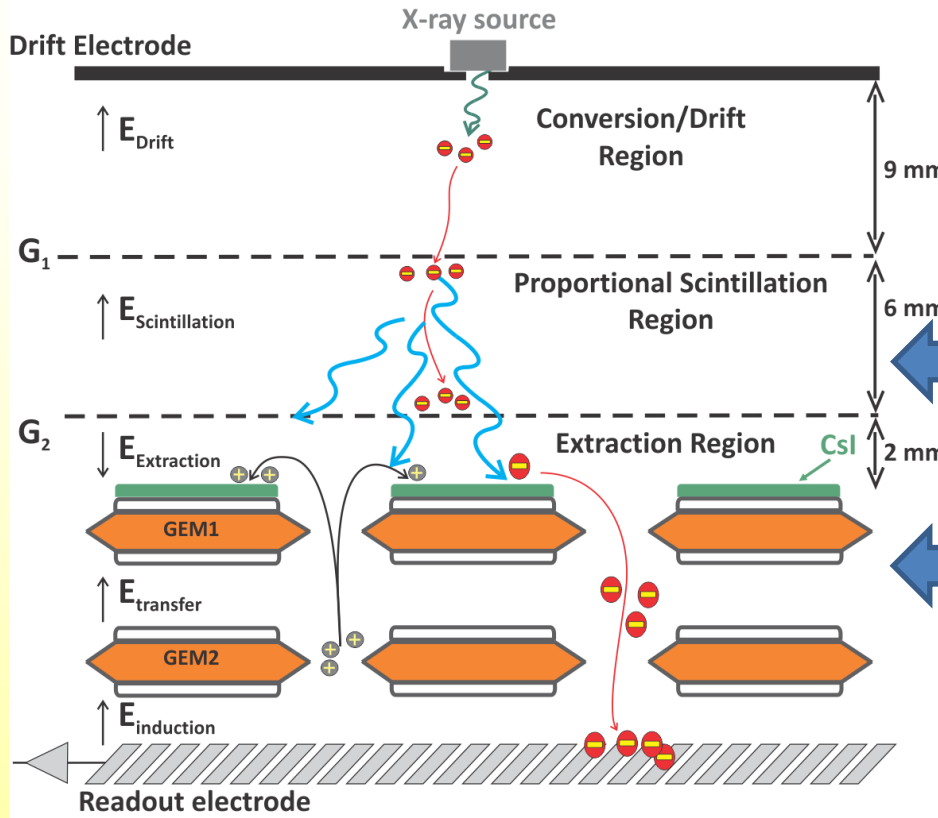
**IBF independent on  
GAIN**

2 ions/primary  
electron (CF<sub>4</sub>)

**NO ions produced in  
the proportional  
scintillation region**

0 ions/primary  
electron  
(only primary  
ionization)

# The Zero Ion Back Flow Electron Multiplier



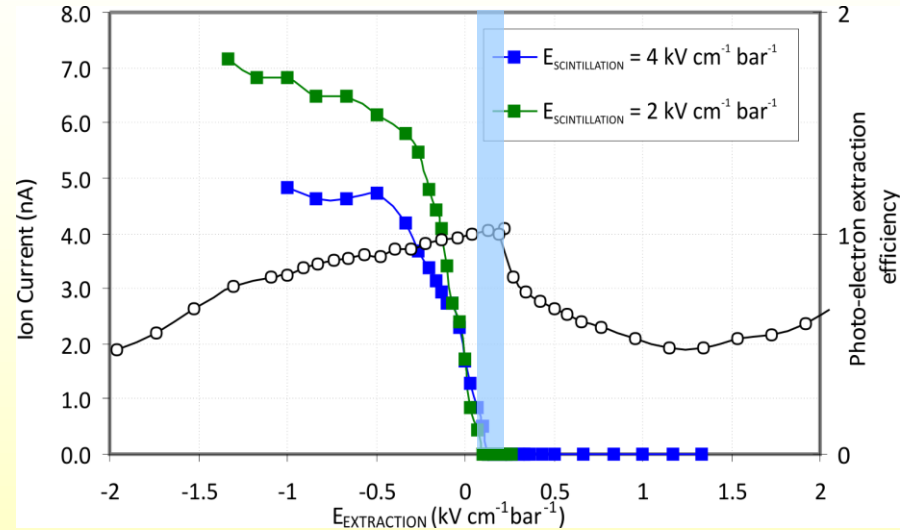
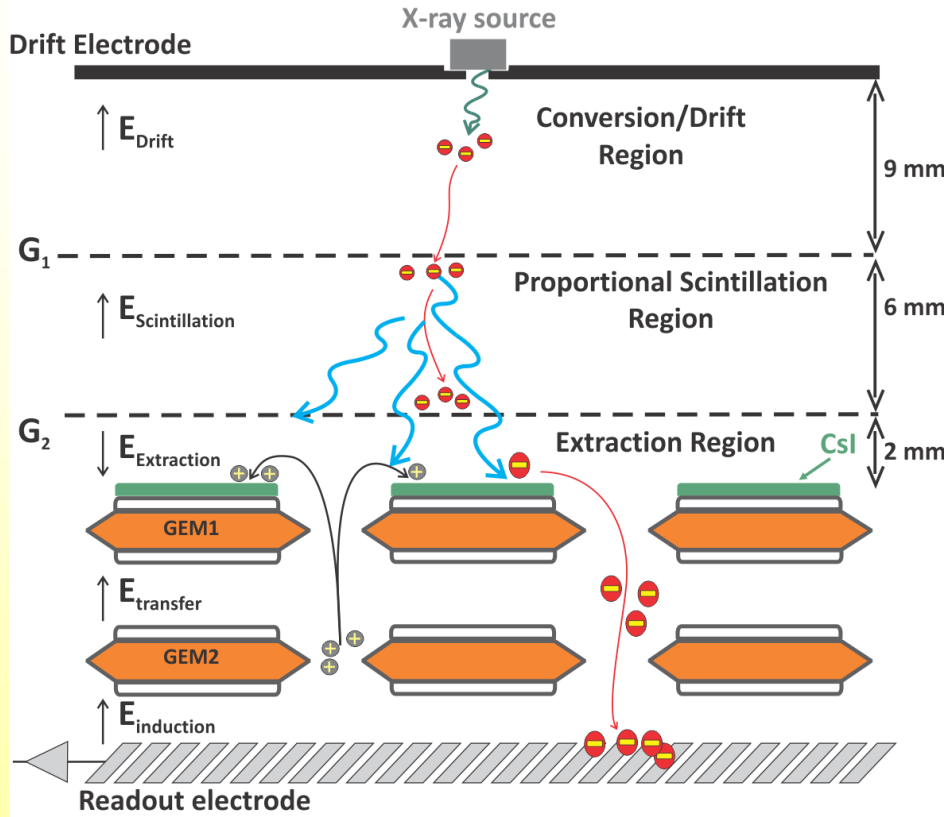
Proportional scintillation region:  
Primary electron cloud drifts under an electric field below the threshold for ionization. No secondary charges are created. Secondary scintillation is produced and emitted isotropically.

Gaseous Photomultiplier:  
Collects a fraction of the secondary scintillation.

The ultimate stage on Ion Back Flow Suppression

Only the primary ions are present on the conversion region. The primary electron cloud is amplified in the detector and no secondary ions return to the conversion region.

# The Zero Ion Back Flow Electron Multiplier



Extraction field plays a critical part on ion back flow suppression as well as in photo-electron extraction

The ultimate stage on Ion Back Flow Suppression

Only the primary ions are present on the conversion region. The primary electron cloud is amplified in the detector and no secondary ions return to the conversion region.

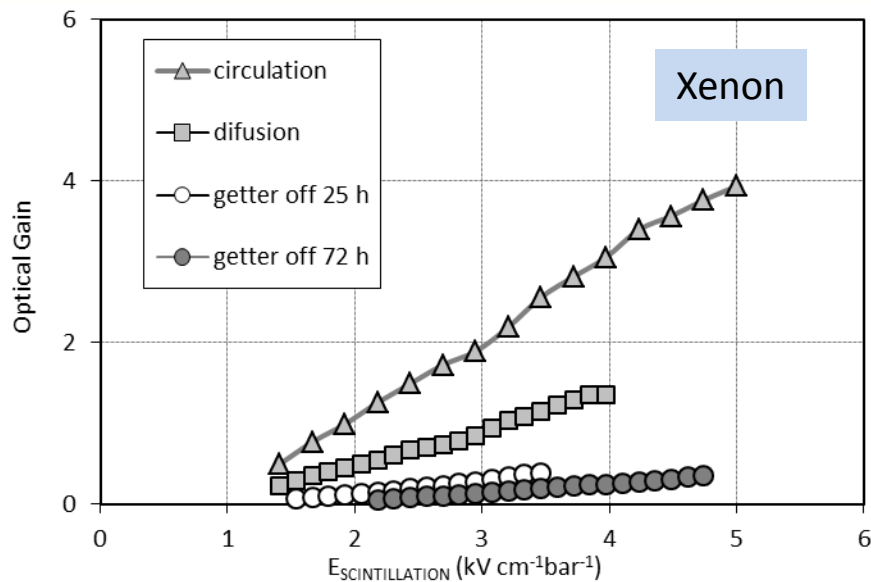
# Optical Gain

*Ratio between the number of photo-electrons detected by the GPM and the number of primary electrons converted in the absorption region.*

$$\text{Optical Gain} \propto N_{ph} \times \Omega \times \text{mesh trans} \times \text{active area CsI} \times Q.E.(\text{CsI}) \times \xi_{ph}$$

- $N_{ph}$  = number of photons emitted per primary electron  
( $\approx 350$  per cm in xenon)
- $\Omega$  = Solid angle subtended by CsI photocathode  
( $\approx 40\%$  for our setup)
- mesh trans = mesh optical transparency
- active area of CsI = % of the GEM covered with copper
- CsI quantum efficiency  $\approx 20\%$  (170 nm)
- $\xi_{ph}$  = photo-electron backscattering

# Optical Gain



The optical gain is strongly dependent on the purity conditions of the gas.

Detector was operated in sealed mode, with the purification done by circulating the gas through non-evaporable getters.

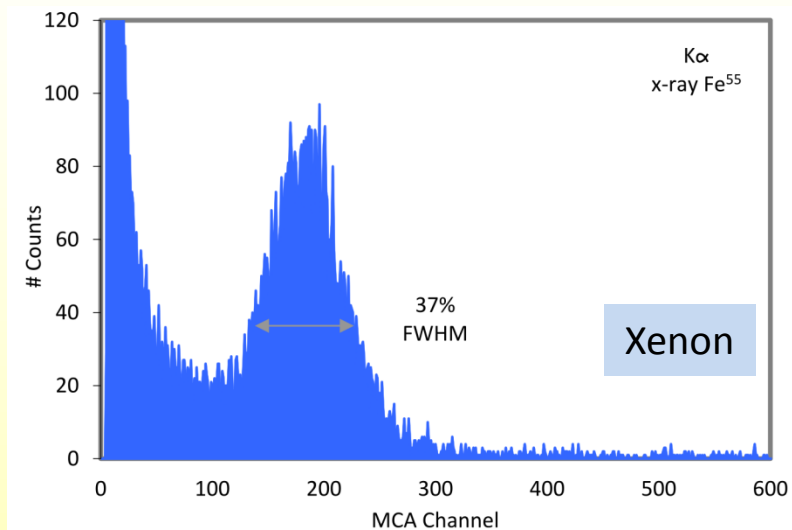
Some geometrical factors that influence the optical gain:

- o proportional scintillation region size (current setup was 6 mm). Increase to 10 mm would increase the optical gain from 4 to 6
- o Larger solid angle (larger photocathode; the one used was 28\*28 mm<sup>2</sup>)

**Despite the relatively modest optical gain, the energy resolution is not compromised**

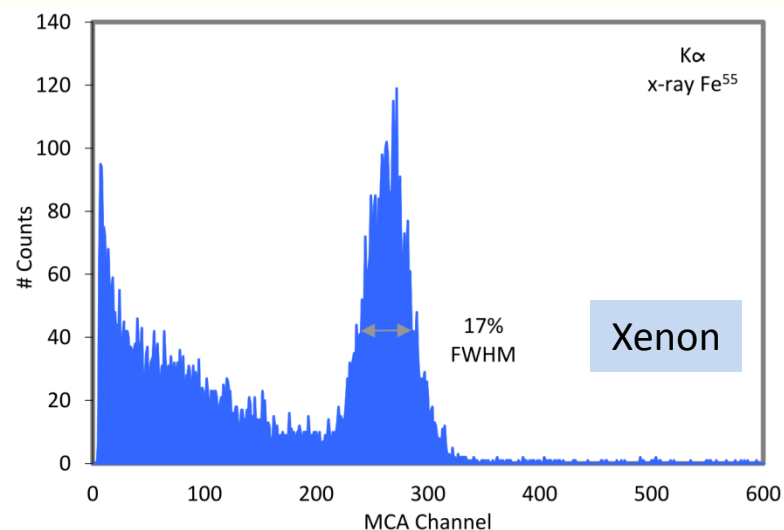
# Energy resolution

## Charge multiplication



Direct signal: resulting from the direct interaction in the gap above the photocathode.

## Scintillation + Charge multiplication



Scintillation signal: 17% energy resolution for an electric field of 4.7 kV cm<sup>-1</sup> bar<sup>-1</sup>



# Zero IBF in Argon

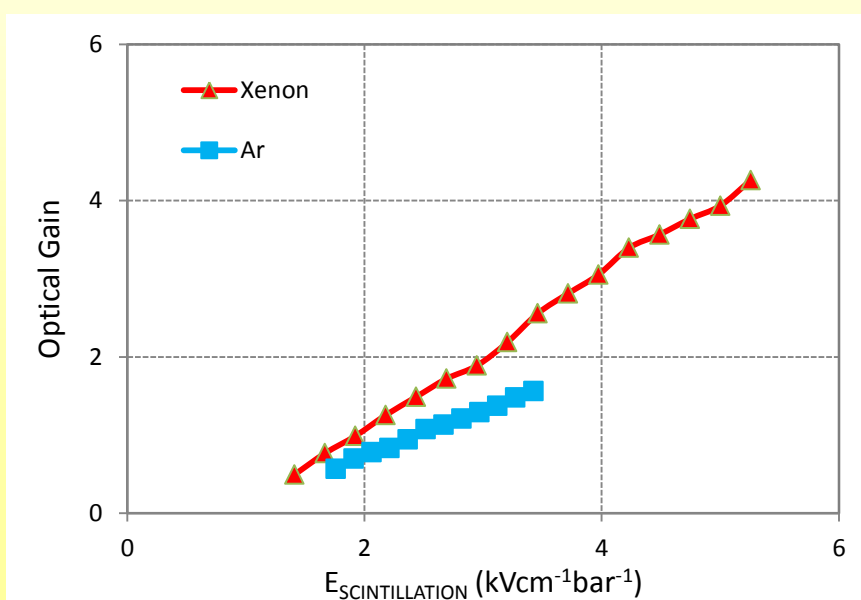
**Optical Gain**  $\propto$  **Nph**  $\times$   $\Omega$   $\times$  mesh trans  $\times$  active area CsI  $\times$  Q. E. (Csi)  $\times$   $\xi_{ph}$

	Xenon	Argon
Nph	203	130
CsI Q.E.	$\approx 20\%$ (170 nm)	$> 35\%$ (120 nm)
PhotoElectron Collection efficiency	$\approx 25\%$	$\approx 45\%$

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Slightly higher optical gains  
expected with Argon

Double GEM  
(Kapton)

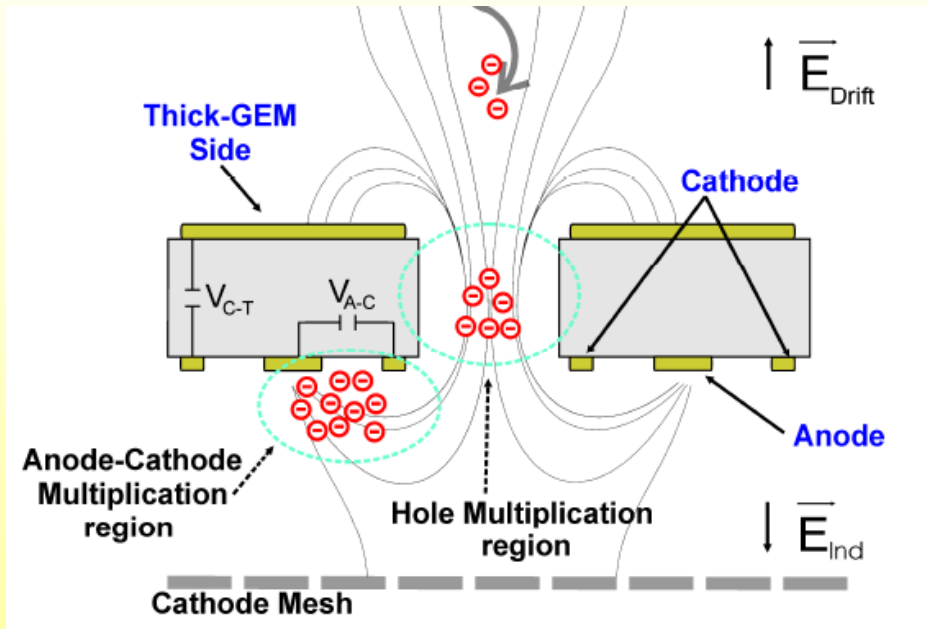
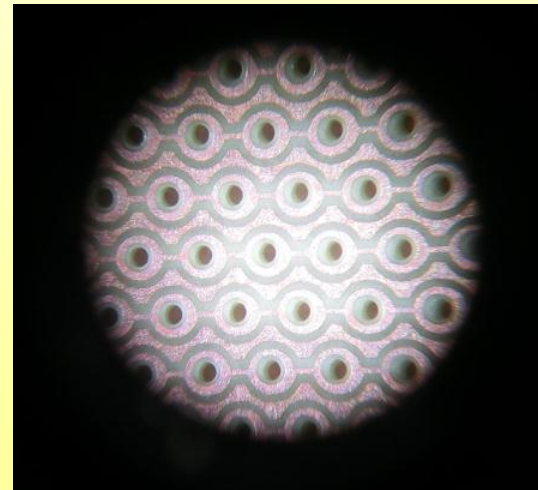
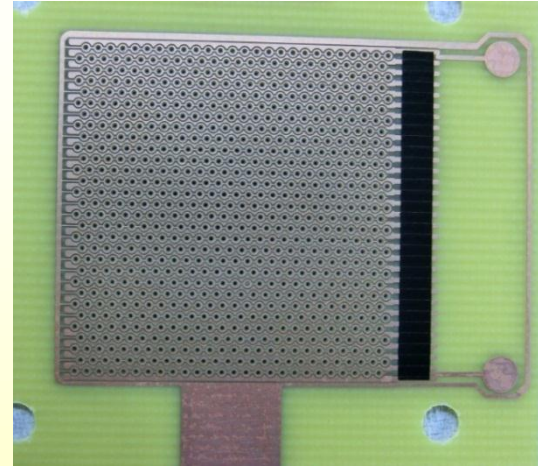


THCOBRA  
Thick Hole multiplier  
(G10)

# THCOBRA

THICK Electron Multiplier.

- 2 Independent Multiplication regions
- Very Robust

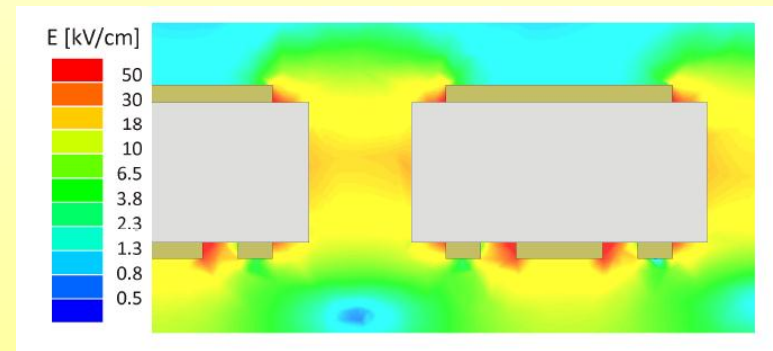
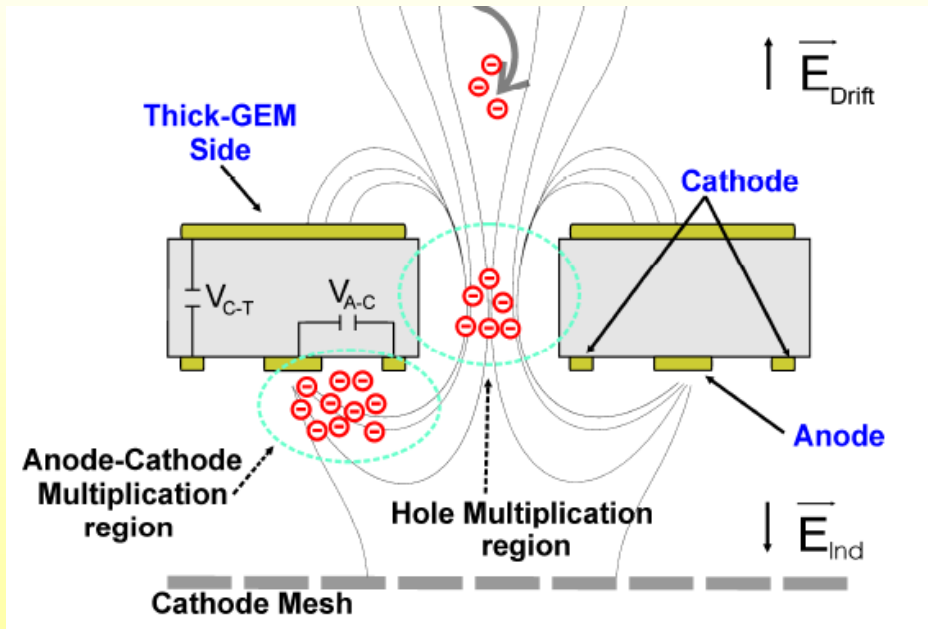
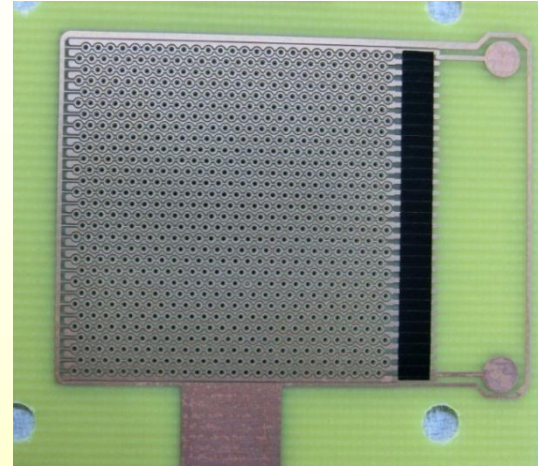


[F D Amaro et al. "The Thick-COBRA: a new gaseous electron multiplier for radiation detectors" 2010 JINST 5 P10002]

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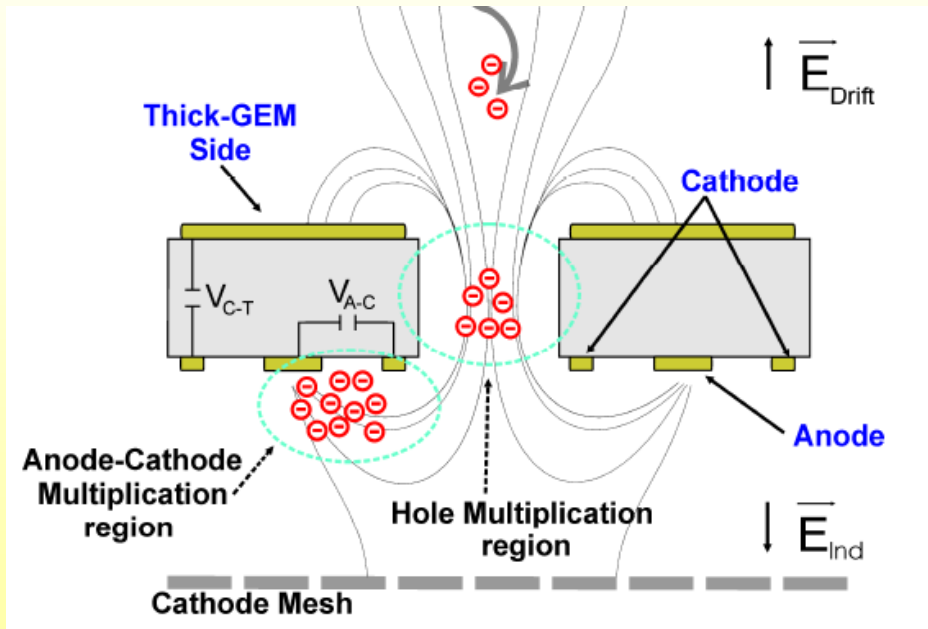
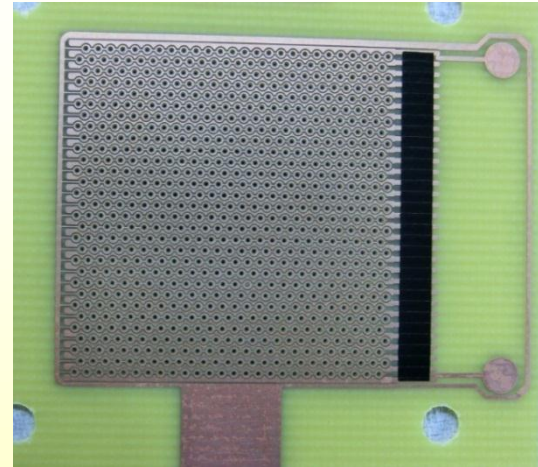


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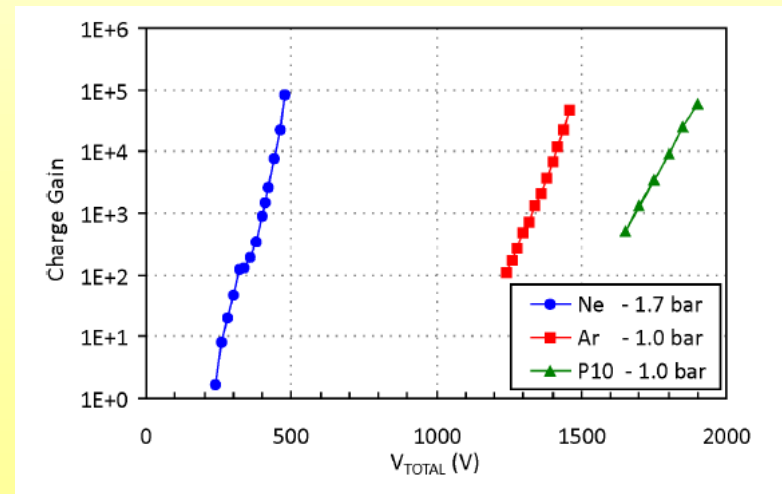
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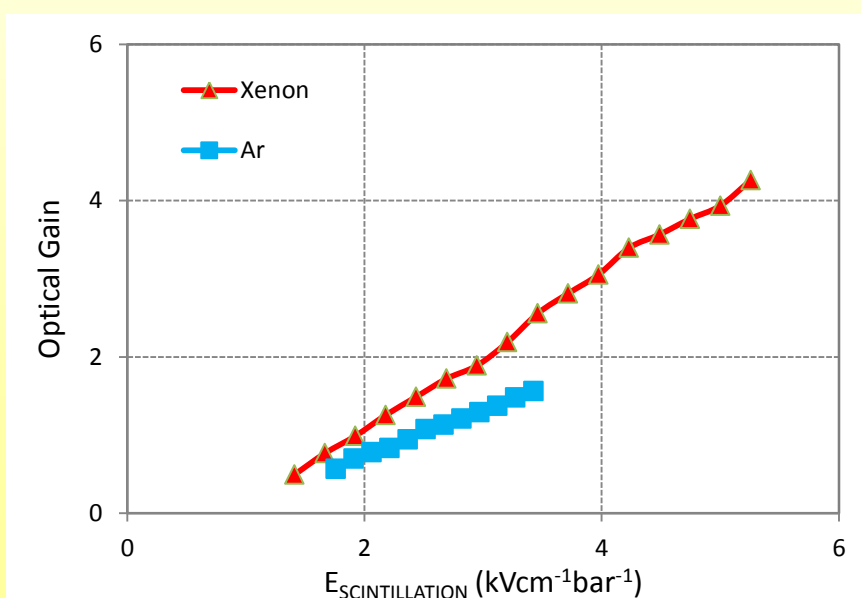
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# Zero IBF in Argon

$$\text{Optical Gain} \propto N_{ph} \times \Omega \times \text{mesh trans} \times \text{active area CsI} \times \text{Q. E. (CsI)} \times \xi_{ph}$$

	Xenon	Argon
N <sub>ph</sub>	203	130
CsI Q.E.	≈ 20 % (170 nm)	> 35 % (120 nm)
PhotoElectron Collection efficiency	≈ 25 %	≈ 45 %



Slightly higher optical gains expected with Argon

Double GEM  
(Kapton)



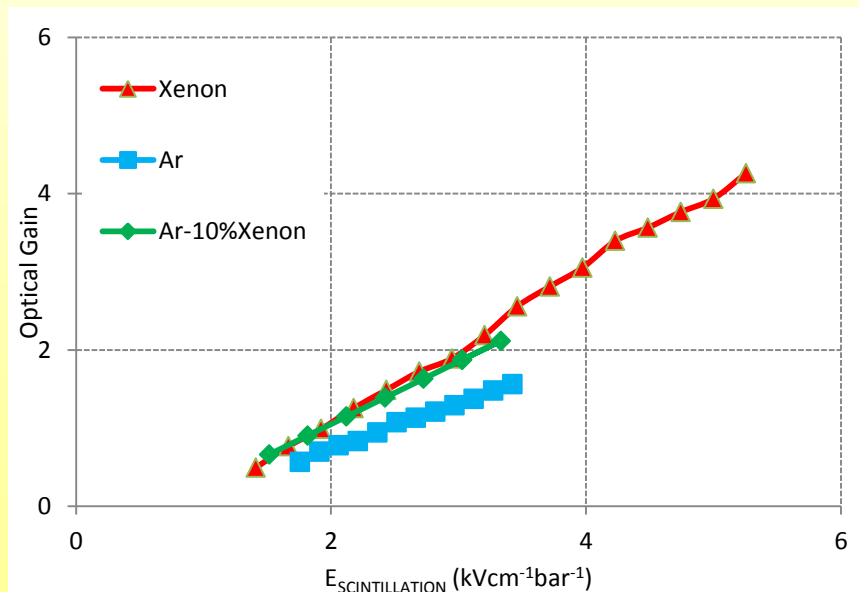
THCOBRA  
Thick Hole multiplier  
(G10)

# Argon-Xenon mixtures

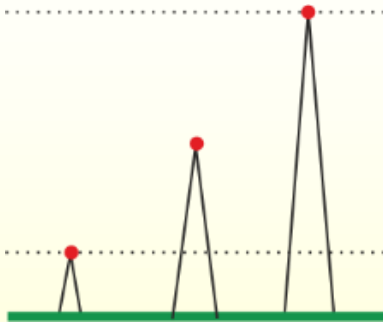
“the best of both worlds”

**Optical Gain**  $\propto$  **Nph**  $\times$   $\Omega$   $\times$  mesh trans  $\times$  active area CsI  $\times$  Q. E. (Csi)  $\times$   $\xi_{ph}$

	Xenon	Argon
Nph	203	130
CsI Q.E.	$\approx 20\%$ (170 nm)	$> 35\%$ (120 nm)
PhotoElectron Collection efficiency	$\approx 25\%$	$\approx 45\%$



# Position information

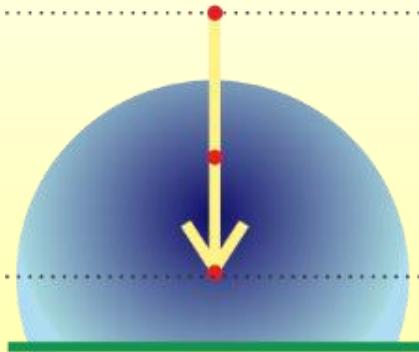


Electroluminescence is emitted isotropically .

Optical Gain of 4



4 photons collected from our photocathode  
per primary electron



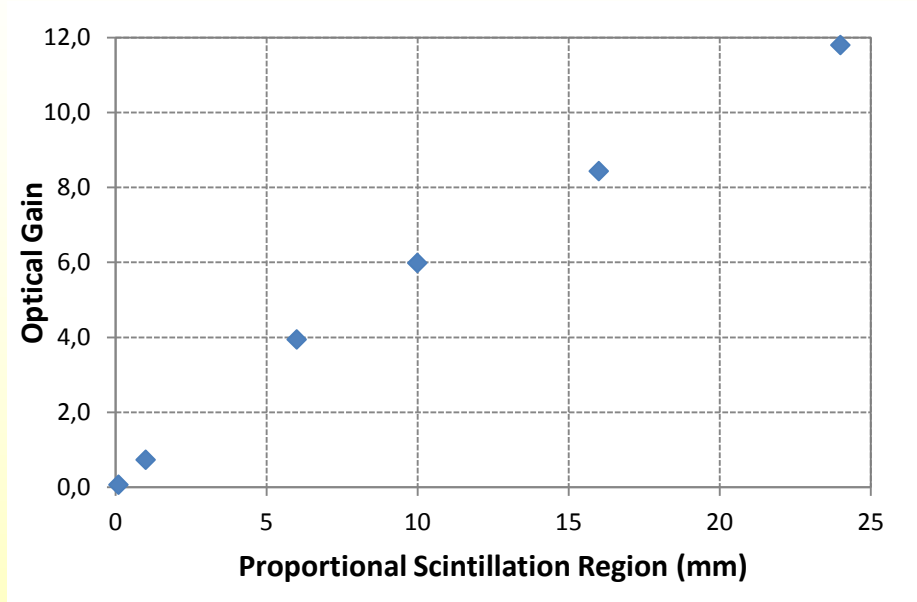
A simple monte-carlo model:

- electron is moving in straight line through the scintillation region
- emits radiation in all directions with a given probability per step.
- The number of photons emitted in each step was adjusted to match our experimental values
- A photo-sensor collects part of this radiation.

No electron diffusion. No primary electron cloud size.  
Only spread from scintillation.



# Optical gain estimation

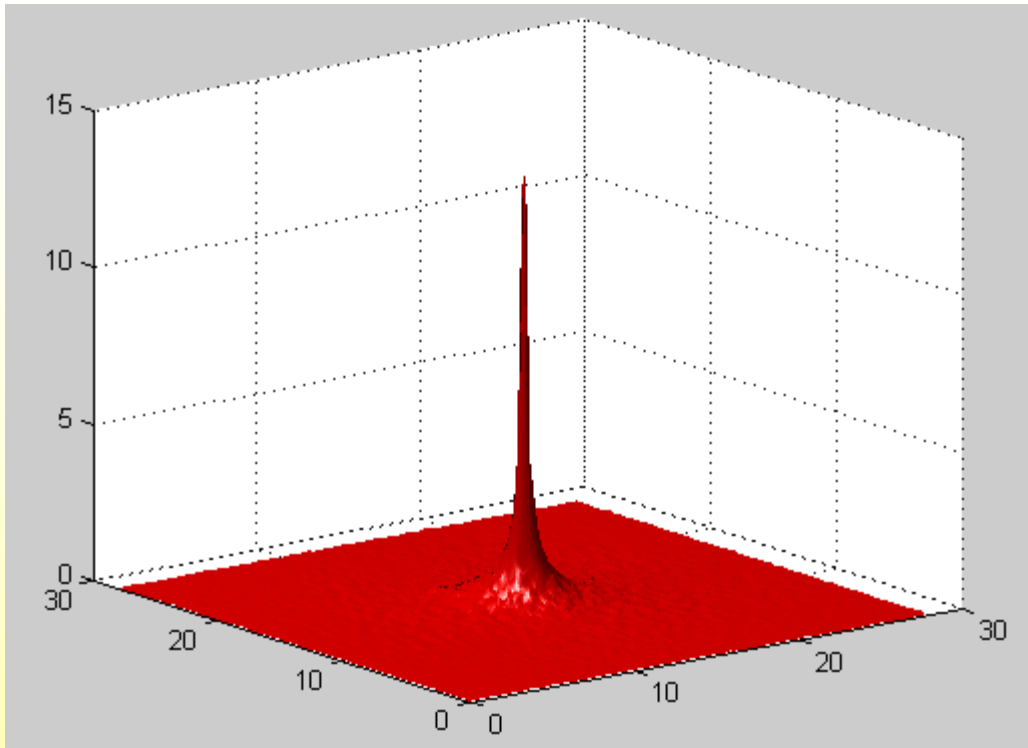


Changing the geometry of our model gives us an estimation of the optical gain as a function of the scintillation region size.

Result calculated from the experimental conditions of our double GEM detector in Xenon:

- 6 mm scintillation region
- 28x28 mm<sup>2</sup> photo-sensor
- optical gain of 4.

# Single electron position correlation



270 primary electrons  $\approx$   
Fe<sup>55</sup> conversion in Xenon

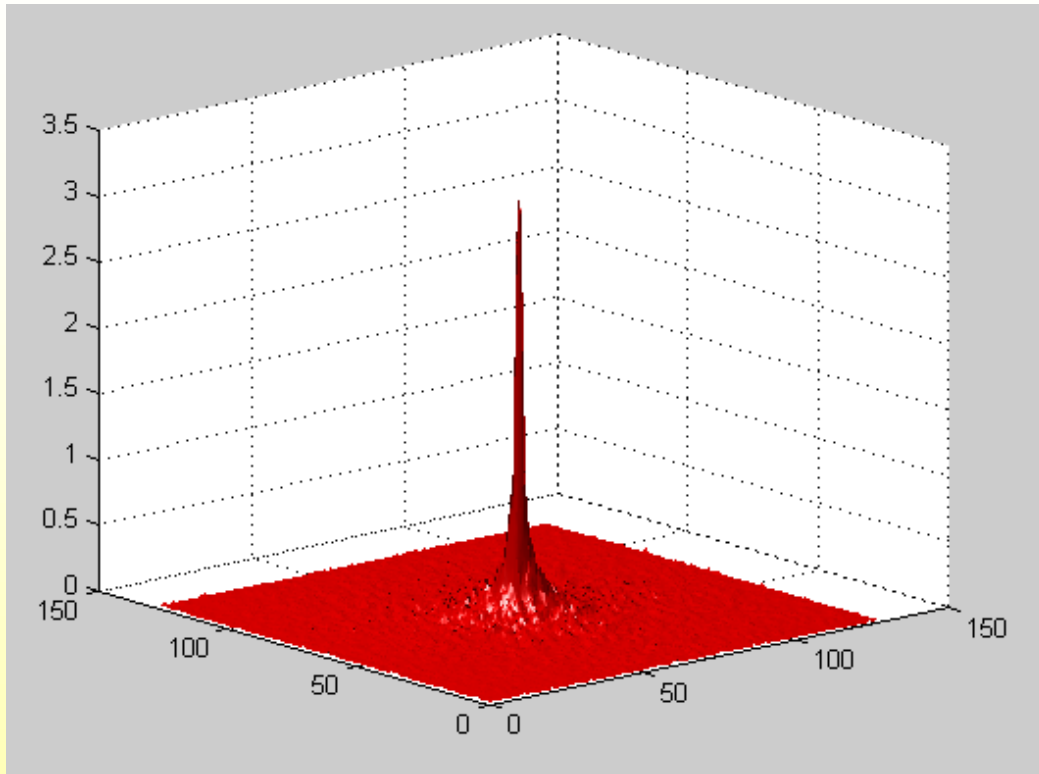
Optical Gain = 4

Nph collected at the  
photocathode = 1080

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- optical gain of 4.

# Single electron position correlation



270 primary electrons  $\approx$   
Fe<sup>55</sup> conversion in Xenon

Optical Gain =1

Nph collected at the  
photocathode = 270

Result calculated from the experimental conditions of our double GEM detector in Xenon:

- 6 mm scintillation region
- 28x28 mm<sup>2</sup> photosensor
- optical gain of 1.

# Conclusions

- R-MHSP: Trapping of ions using the strips on the bottom of the MHSP  
Works in Ar/CH<sub>4</sub> mixtures  
6 ions/primary electron  
Successful operation of visible sensitive GPM
- Photon Assisted Cascaded Electron Multiplier  
Noble Gases and CF<sub>4</sub> and their mixtures  
2 ions/primary electron in CF<sub>4</sub>
- Zero IBF cascaded electron multiplier  
Works in noble gases  
Ultimate stage on ion suppression → primary ions

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